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MEMS Sensor Testing Challenges and Requirements

Nigel Beddoe

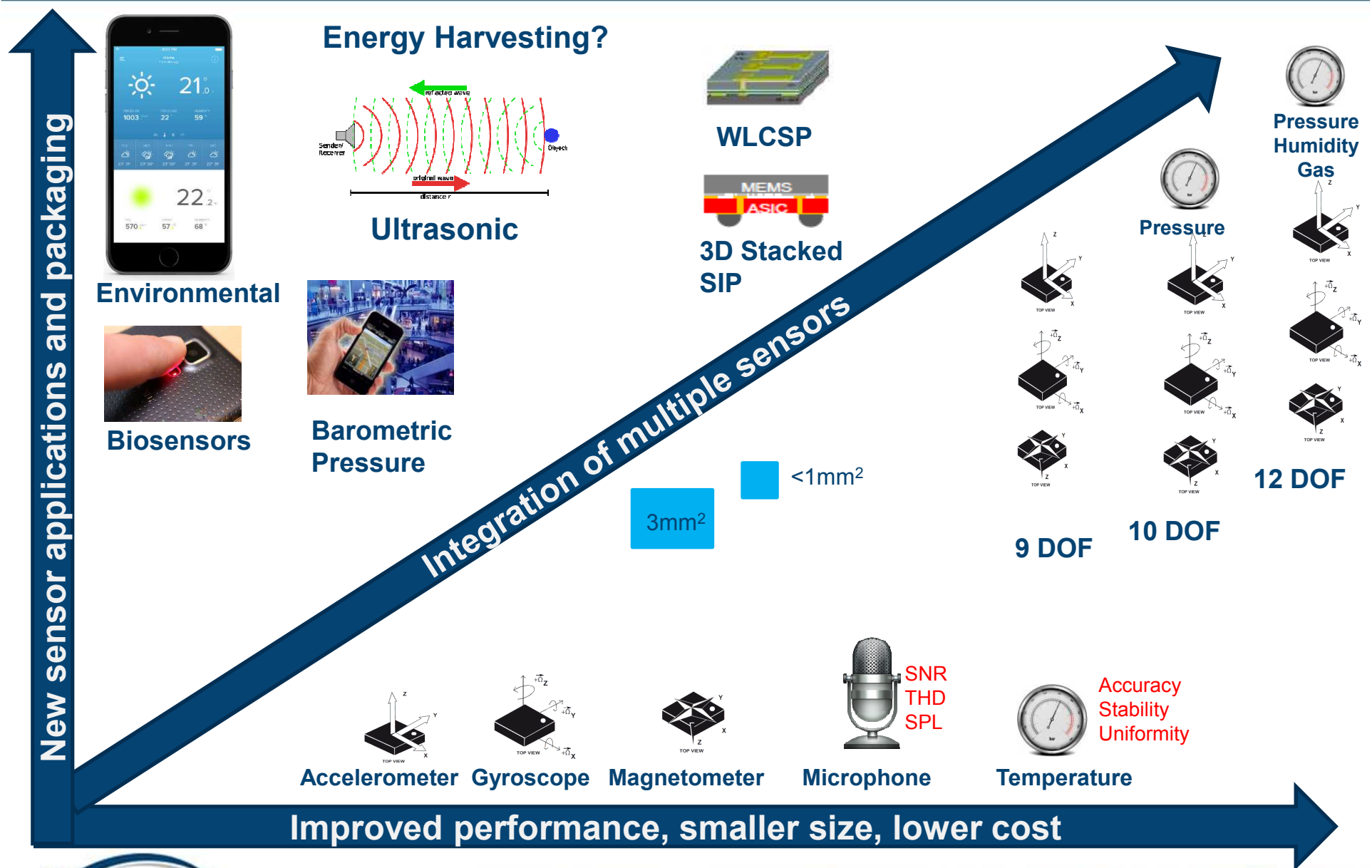
Xcerra Global Business Development



Agenda

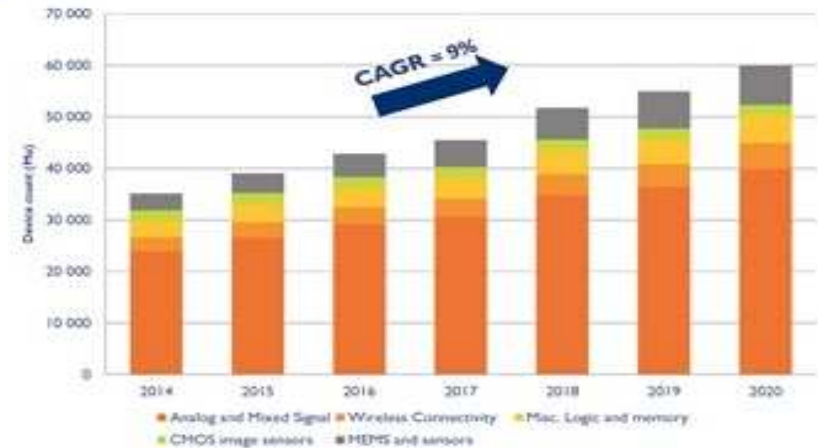
- ❑ Sensor Trends and Market Drivers
- ❑ Sensor Testing Challenges
- ❑ Sensor Testing Requirements
- ❑ Sensor Test Cell for High Volume Manufacturing

Sensors Trends

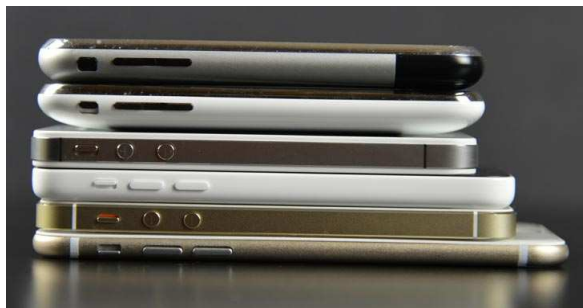


Sensor Trends WLCSP

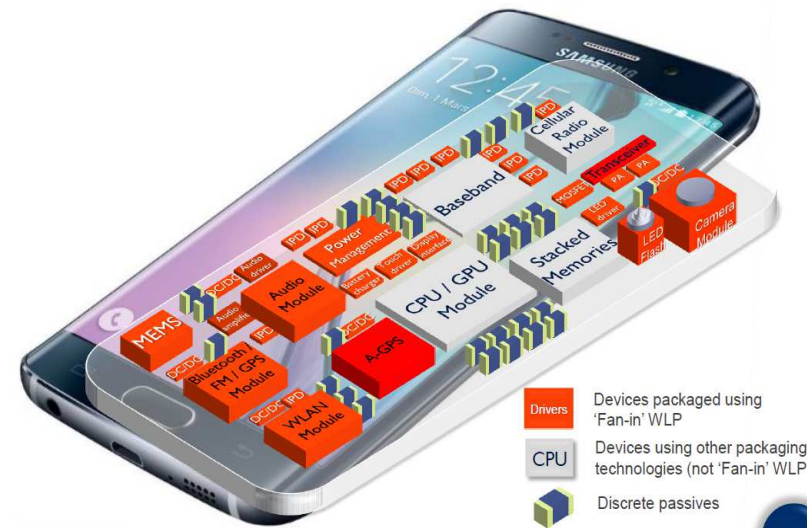
- ❑ Wafer Level Package (Fan-In) unit count is growing at a CAGR of 9% between 2014 and 2019.
- ❑ Demand for WLCSP driven mainly by mobility customers due to low cost and smaller form factor (<50mm²)
 - ❑ **Sensors**, Connectivity, PMIC, Touch Controller, Camera, Transceiver/PA,.....
- ❑ Automotive and Internet of Things markets expected to grow MEMS WLCSP



Fan-in Wafer Level Packaging Market and Technology Trends Report, Yole Development May 2015



Evolution of the iPhone

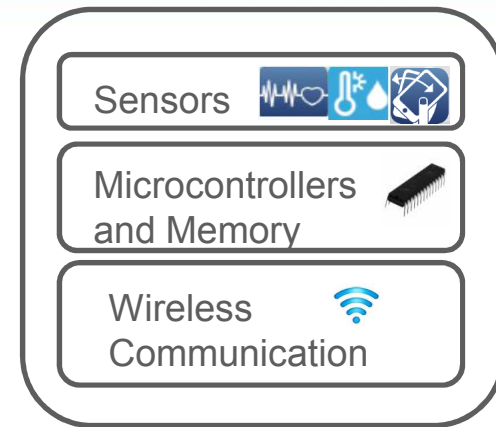


- Drivers
- Devices packaged using 'Fan-in' WLP
- Devices using other packaging technologies (not 'Fan-in' WLP)
- Discrete passives

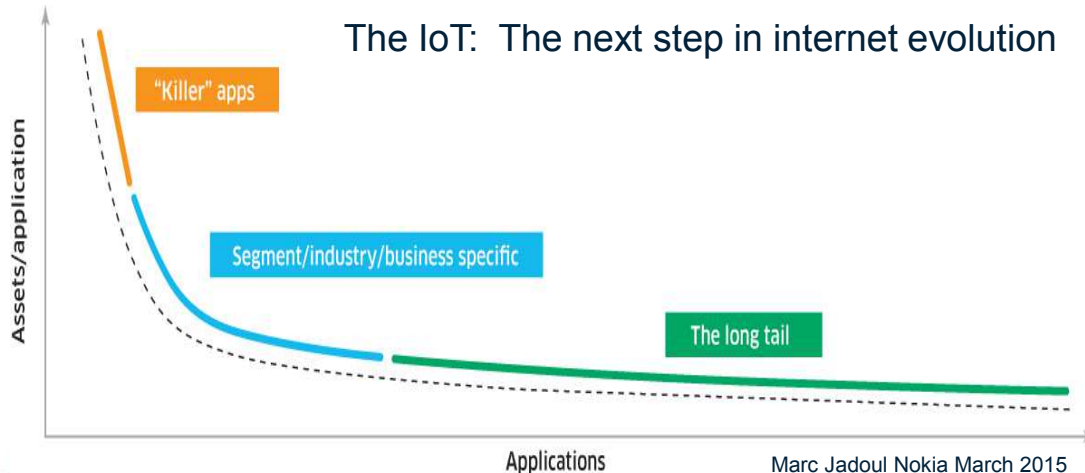
©2015 | www.yole.fr | Fan-in WLP: Market and Industrial Trends

Sensor Trends Internet of Things

- ❑ The number of IoT connected devices is expected to grow to 30 – 50B devices by 2020.**
- ❑ Wide variety of sensors needed to cover the long tail of applications in every market segment.
- ❑ IoT will drive higher levels of integration of sensors, microcontrollers and RF in new innovative packaging (SiP, 3D,...).



Connected Smart Things



The "Thing" that senses our world

Sources: ** (Cisco, Gartner)
 Images from Nest, Philips, Fitbit, iCon

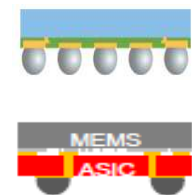
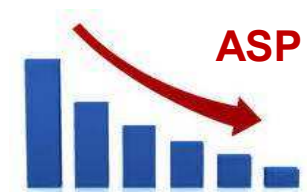
Sensor Testing Challenges

- ❑ Stringent technical specifications
 - ❑ New sensors require higher performance and better accuracy
 - ❑ High performance sensors for competitive advantage and higher ASP

- ❑ High volume production and low Cost of Test
 - ❑ Billions of sensors shipped every year
 - ❑ High parallelism and UPH
 - ❑ Faster time to market

- ❑ Higher levels of integration
 - ❑ Multiple sensors integrated with demanding test challenges

- ❑ New technologies and applications
 - ❑ Innovative and smaller packaging (WLCSP, SiP, 3D, Embedded)
 - ❑ New sensor applications
 - ❑ Sensors for all markets (consumer, automotive, medical, industrial...)



Sensor Testing for High Volume Manufacturing (HVM)

- ❑ Custom bench top engineering lab systems struggle to meet HVM requirements.
 - ❑ SITRI has the Xcerra solution which not only meets the engineering R&D requirements but is also capable of HVM production.

- ❑ HVM requires fully automated test cell that output millions of different sensor devices per month for low Cost of Test.

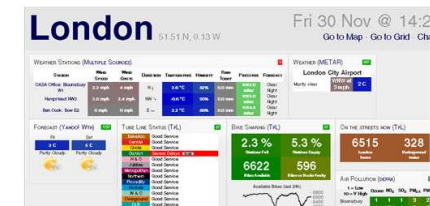
- ❑ Testing high accuracy specification sensor devices can be challenging in HVM.
 - ❑ High accuracy stimulus with high parallelism
 - ❑ Temperature accuracy and uniformity for large number of devices
 - ❑ Stable test conditions (low drift during test)
 - ❑ Isolation of test from environment (temperature/humidity, noise and vibration of test floor)
 - ❑ SNR requirements for Microphones
 - ❑ Achieving highest first pass yield

Environmental Sensors

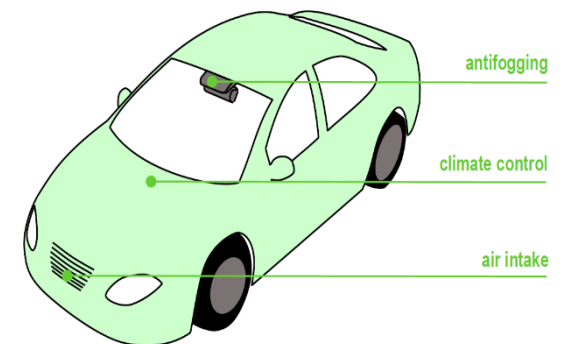
- ❑ Growth of environmental sensors driven by smart devices
- ❑ Combination of pressure, temperature, humidity and gas in the same package
- ❑ Ideal Gas Law $PV=nRT$, model to predict the behavior of gas
 - ❑ Pressure related to temperature.
 - ❑ Humidity related to pressure and temperature.
- ❑ HVM test cell needs advanced temperature capability to meet stringent test requirements
 - ❑ Temperature Accuracy $\pm 1^\circ\text{C}$
 - ❑ Temperature Uniformity $\pm 0.5^\circ\text{C}$
- ❑ Need stable test environment before start of test
 - ❑ Fast pressure switching time



Image by BeeWi



CITY DASHBOARD



Temperature Performance

InBaro 125 degC Temperature Accuracy and Uniformity

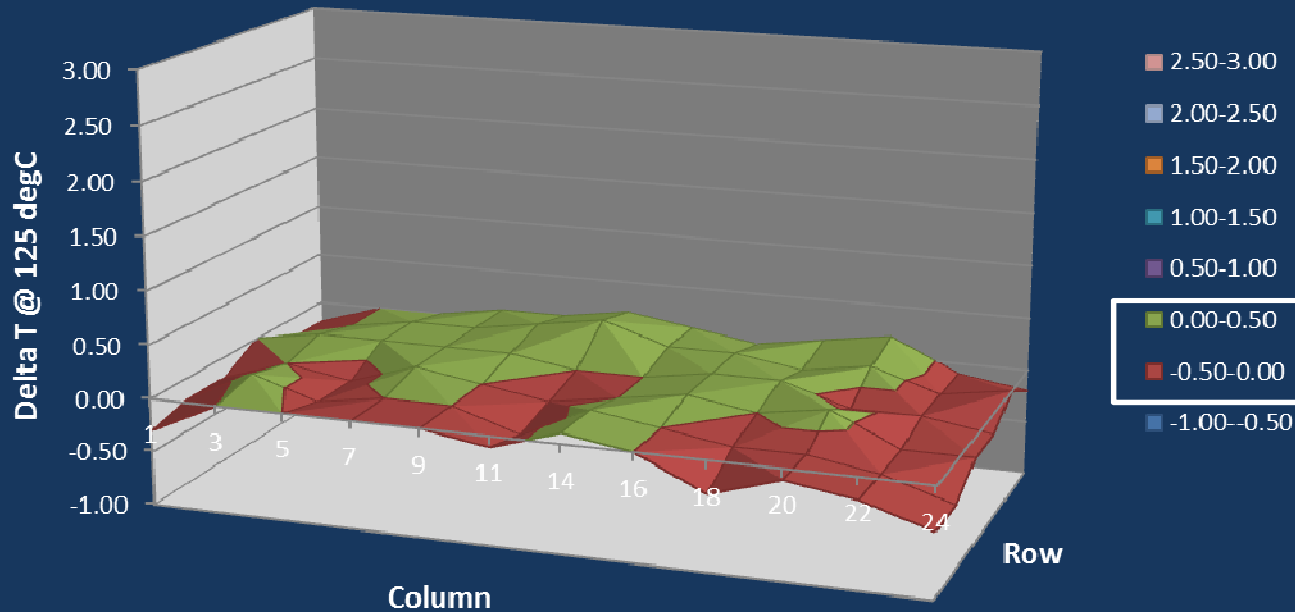


Diagram displays delta T of +/-0.5°C at 125.6°C over nest array

Performance

min	125.2	°C
max	125.9	°C
mean	125.6	°C

Setup Tolerance

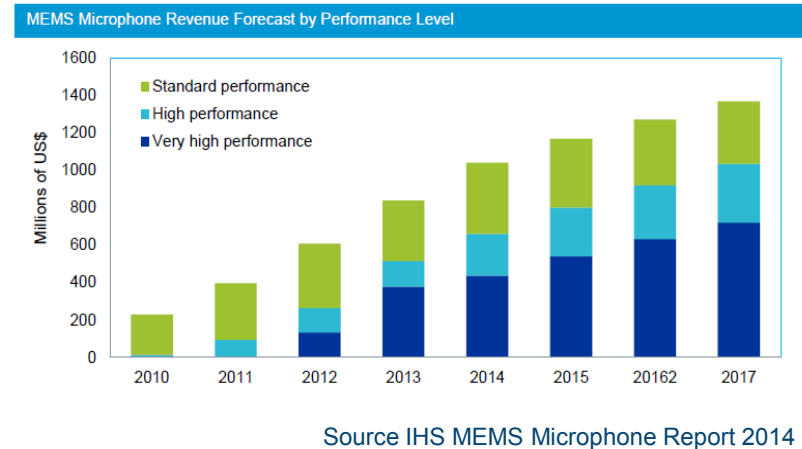
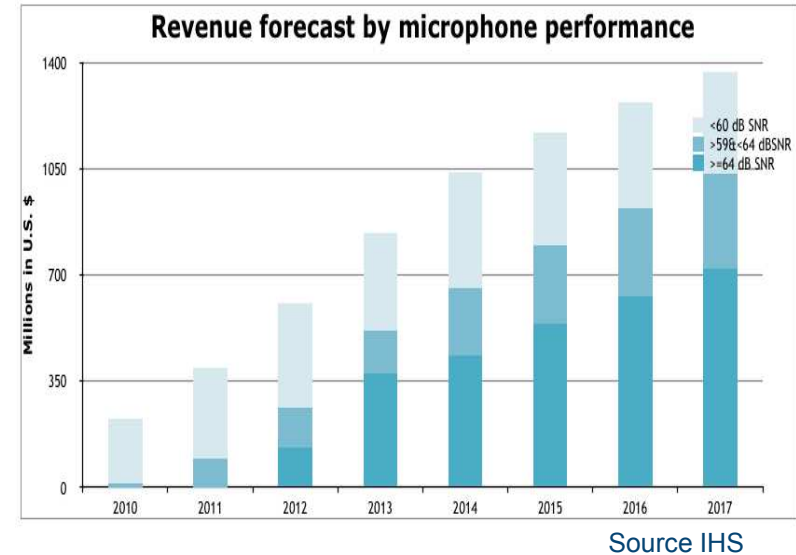
PT100 Class A Tolerance		
dT = +- (0,15 degC + 0,002 x T)		
T=	125.60	°C
dT= ±	0.40	°C
T(max)	126.00	°C
T(min)	125.20	°C

MEMS Microphones

- ❑ Strong growth with the adoption of multiple microphones in consumer and mobility applications for noise cancellation, accurate voice recognition and HD video recording.
 - ❑ Future smart phones/ear buds will require up to 10 microphones

- ❑ Test solutions for previous generation microphones are not able to meet the technical and volume requirements for future high performance microphones
 - ❑ Need high parallel automated test solutions. Today solutions are able to test //144 sites.

- ❑ New technical requirements
 - ❑ Signal to Noise Ratio (SNR) 75dB
 - ❑ Sound Pressure Level (SPL) 140dB
 - ❑ Total Harmonic Distortion (THD) <0.5%
 - ❑ Digital output
 - ❑ Emerging ultrasonic applications



Optical Sensors

- ❑ Broad range of applications
 - ❑ Light detection for smart phone/home/automobile, bio-sensing (temperature, heart rate monitoring, blood oxygenation), gesture, proximity

- ❑ Test challenges:
 - ❑ Requires a wide range of light sources
 - ❑ RGB, ambient, multiple IR wave lengths, UV
 - ❑ Devices are small and fragile (chip on glass)
 - ❑ May need access to both sides of the device
 - ❑ May require testing at temperature
 - ❑ High volumes



Image by Samsung



Source: Check Your Kid's Fever with Your Cell Phone? Samantha Gregory, Nov 2012



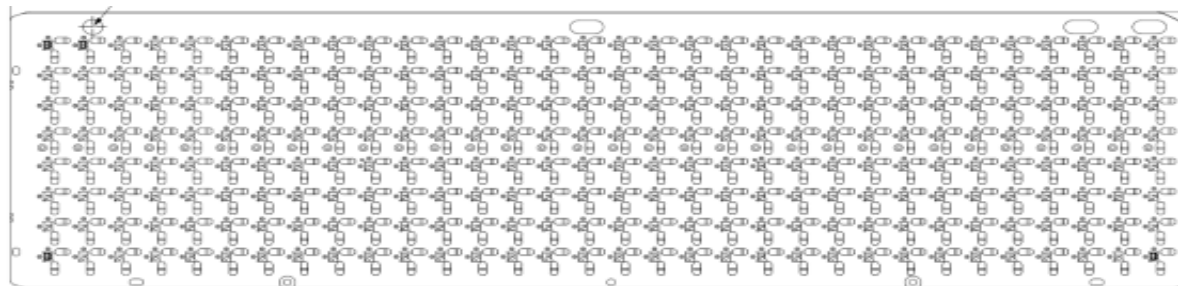
Source: Home Automation Internet Gateway Bandwidth Requirements, Paul Williams, July 2015

High Parallelism and UPH

- ❑ To ship billions of sensors per year and get low Cost of Test, you need high UPH and parallelism
 - ❑ Minimize total test cells and CAPEX to meet volume demand
 - ❑ Minimize floor space, operators, maintenance, ...



- ❑ Today 256 sites in a single touchdown. Target future +300 sites in parallel.
- ❑ Challenges in HVM
 - ❑ Handling large quantity of devices in parallel
 - ❑ Uniformity of stimulus
 - ❑ Uniformity of temperature across all devices throughout test for high yield
 - ❑ Contacting fine pitch devices (0.3mm)



InCarrier for //256 sites parallel test

Sensor Integration

- ❑ Need to test multiple DOF or stimulus
 - ❑ 9DOF inertial sensors
 - ❑ Environmental combo devices (pressure, temperature, humidity, gas)
 - ❑ 10/11/12 DOF: 9DOF + environmental, 9DOF + microphone
 - ❑ Fingerprint + optical

- ❑ Integration with other devices
 - ❑ Sensor, microcontroller, memory, RF and smart power

- ❑ Wide variety of packages and sizes
 - ❑ Multi-chip packages, caps, chip-on-glass, 3D...

- ❑ New requirements
 - ❑ Modularity to test all types of sensors
 - ❑ Flexibility to test all package types
 - ❑ Minimum number of insertions
 - ❑ Tester capable of testing integrated IoT devices

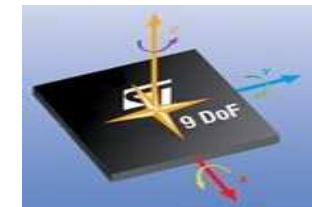


Image by ST

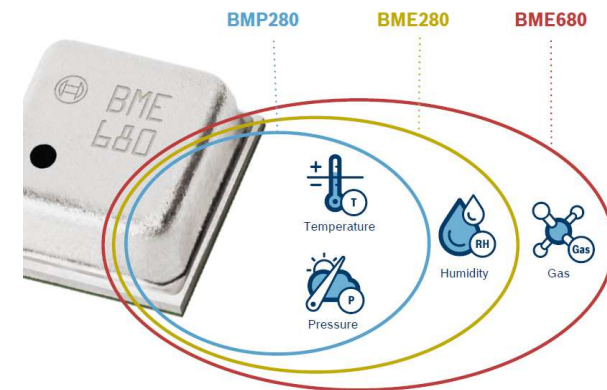


Image by Bosch

Testing MEMS WLCSP

- ❑ Growth in MEMS WLCSP
- ❑ Requires post saw test on singulated MEMS to ensure quality
- ❑ Challenges of handling MEMS WLCSP
 - ❑ Small size and thickness 1x1x0.2mm
 - ❑ Handler and MEMS stimulus needs to transport fragile singulated die
 - ❑ Minimizing handling steps challenging for pick and place handlers
- ❑ Other requirements
 - ❑ Input wafer ring/blue tape, output tape and reel
 - ❑ Stringent vision inspection requirements
 - ❑ Device tracking
 - ❑ RMA and retest challenges of WLCSP devices

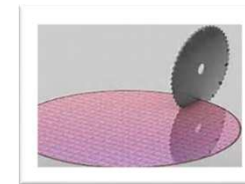
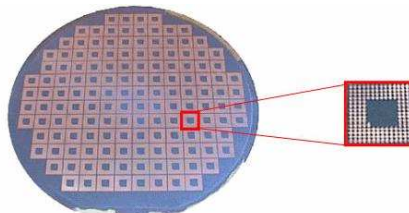
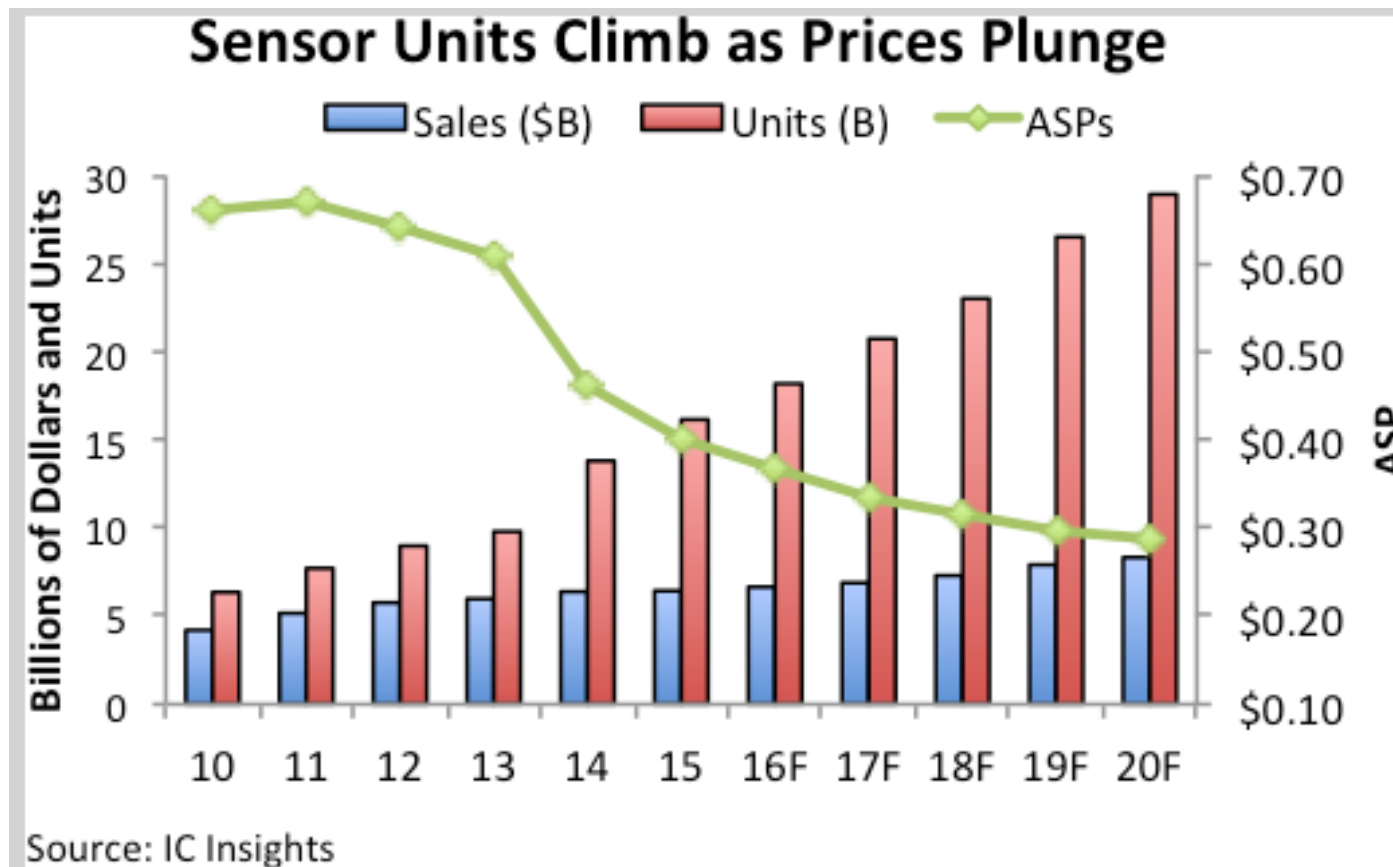


Image by Gila Tool

Record Sensor Unit Shipments and Revenues

Wearables, vehicle automation and Internet of Things

- Unit shipment CAGR 12.4% 2015 – 2020
- Revenues CAGR 5.3% 2015 – 2020
- ASP CAGR -5.7% 2015-2020 (biggest decline in discrete inertial sensors)



Sensor Test Cell for High Volume Manufacturing

- ❑ Fully automated test cell solution
 - ❑ Proven technical capability and experience in MEMS/sensor test
 - ❑ Advanced tri-temperature capability
 - ❑ Highest stimulus performance and accuracy
 - ❑ Highest parallelism and UPH
 - ❑ Integrated and optimized test cell for fast ramp and highest performance

- ❑ Flexible
 - ❑ High Return on Investment
 - ❑ Multi-use equipment for all types of devices (MCU, wireless,)
 - ❑ Standardized equipment instead of dedicated MEMS solutions
 - ❑ Modular MEMS stimulus for a wide range of sensor types
 - ❑ Ability to test integrated sensors with single insertion
 - ❑ Handle diverse package types and sizes on same equipment
 - ❑ WLCSP, strip, packages, less than 1x1mm size
 - ❑ Simple and fast change kit conversion



InStrip with InFlip MEMS Test Cell

InMEMS Modules Available for InStrip

InFlip / InFlipM
Accelerometer Magnetometer



InBaro / InHumid / InGas
Environmental Combo



InGyro
9DOF



InPressure
TPMS



InStrip Base Unit

InPhone
Microphone





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Thank You

